

INVENTOR INFORMATION

Inventor One Given Name:: Hideto  
Family Name:: OHNUMA  
Postal Address Line One:: c/o Semiconductor Energy Laboratory Co., Ltd  
Postal Address Line Two:: 398, Hase,  
City:: Atsugi-shi  
State or Province:: Kanagawa-ken  
Country:: Japan  
Postal or Zip Code:: 243-0036  
Citizenship Country:: Japan

CORRESPONDENCE INFORMATION

Correspondence Customer Number:: 22204  
Fax One:: (703) 883-0370  
Electronic Mail One:: pluther@nixonpeabody.com

APPLICATION INFORMATION

Title Line One:: METHOD OF MANUFACTURING SEMICONDUCTOR DE  
Title Line Two:: VICE  
Total Drawing Sheets:: 13  
Formal Drawings?:: Yes  
Application Type:: Utility  
Docket Number:: 740756-2422  
Secrecy Order in Parent Appl.?:: No

REPRESENTATIVE INFORMATION

Representative Customer Number:: 22204  
Registration Number One:: 38285  
Registration Number Two:: 35483  
Registration Number Three:: 45285  
Registration Number Four:: 32815  
Registration Number Five:: 26477

PRIOR FOREIGN APPLICATIONS

Foreign Application One:: 2001-019293  
Filing Date:: 01-26-2001  
Country:: Japan  
Priority Claimed:: Yes

Source:: PrintEFS Version 1.0.1